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MAR 2 8 2002 In the United States	Patent and Trademark Office
Secial Number 10/039,954	A CONTRACTOR OF THE CONTRACTOR
Appn. Filed: 12/3//200/	
Applicant(s): Seujeung Par,	<u>k</u>
Appn. Title: Imaging-based distant	- F FOUNTIE TIEC
Examiner/GAU:	three-dimensional profiling system
·	Mailed: Manch, 19, 2002
	At: San Jose, CA
Information	Disclosure Statement
Assistant Commissioner for Patents Washington, District of Columbia 20231	
Sir.	
Attached is a completed Form PTO-1449 and copies of the p	periment parts of the references cited infereor, Following are comments of
any non-English-language references pursuant to Rule 98:	
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Very respectfully, Applicant(s):	RECEIVED FEB 0 4 2003
Very respectfully,  Applicant(s):  Enc.: PTO-1449 & References	RECEIVED FEB 0 4 2003 Technology Center 2600
Very respectfully,  Applicant(s):  Enc.: PTO-1449 & References  c/o:  Seujeung Park, App	RECEIVED FEB 0 4 2003
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Very respectfully,  Applicant(s):  Enc.: PTO-1449 & References  c/o:  Seujeung Park, App	RECEIVED  FEB 0 4 2003  Technology Center 2600  FEB 0 5 2003  Stront Proce

Certificate of Mailing

I certify that this correspondence will be deposited with the United States Postal Service as first class mail with proper postage affixed in an envelope addressed to: "Assistant Commissioner for Patents, Washington, DC 20231" on the date below.

Date:

3/19/2002

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Form 10-5

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